

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10789809
	Filing Date		2004-02-27
	First Named Inventor	Trevor W. Freeman	
	Art Unit	2439	
	Examiner Name	Benjamin A Kaplan	
	Attorney Docket Number	MS1-1747US	

U.S.PATENTS						
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
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	1	Heinl, et al., "A Comprehensive Approach to Flexibility in Workflow Management Systems", WACC 1999, ACM, 1999, pp 79-88	<input type="checkbox"/>

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